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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/662,934 09/15/2003		Catherine A. Morley	17310-293333	2027	
7590 04/19/2005			EXAM	INER .	
FAEGRE & BENSON LLP			AHMED, SHAMIM		
2200 Wells Fargo Center 90 South Seventh Street			ART UNIT	PAPER NUMBER	
Minneapolis, MN 55402-3901			1765		

DATE MAILED: 04/19/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Paper U.S. Patent and Tr	No(s)/Mail Date		6)		
1) Notice 2) Notice 3) Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTC nation Disclosure Statement(s) (PTO-1449 or PT	TO/SB/08)			2)
Attachment	t(s)			,	
*S	see the attached detailed Office action	for a list of the certif	ed copies not receive	d.	
	application from the International	al Bureau (PCT Rule	17.2(a)).		-
	3. ☐ Copies of the certified copies of				ge
	1. Certified copies of the priority do2. Certified copies of the priority do			an No	
a)[☐ All b)☐ Some * c)☐ None of:				
_	Acknowledgment is made of a claim fo	or foreign priority und	er 35 U.S.C. § 119(a)	-(d) or (f).	
Priority u	ınder 35 U.S.C. § 119				
11) <u>□</u> 1	The oath or declaration is objected to a	by the Examiner. No	te the attached Office	Action or form PTO-1	152.
	Replacement drawing sheet(s) including the	•	• • • • •		` '
	Applicant may not request that any objecti				
í	The specification is objected to by the The drawing(s) filed on <u>15 September</u>		ccepted or b) 🖾 object	ted to by the Examine	er.
	The specification is objected to by the	Evaminor			
Applicati	on Papers				
	Claim(s) are subject to restriction	on and/or election re	quirement.		
	Claim(s) is/are objected to.				
· <u> </u>	Claim(s) is/are allowed. Claim(s) <u>1-32</u> is/are rejected.				
	4a) Of the above claim(s) is/are	withdrawn from cor	sideration.		
	Claim(s) 1-32 is/are pending in the ap	•			
Dispositi	on of Claims				
	closed in accordance with the practice	s unuer Ex parte Qua	ayıe, 1935 C.D. 11, 45	oo U.G. 213.	
3)[Since this application is in condition for		•		erits is
· ·		o)⊠ This action is no			
1	Responsive to communication(s) filed				
Status					
THE I - Exter after - If the - If NO - Failu Any r earne	MAILING DATE OF THIS COMMUNIC nsions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this communication for reply specified above is less than thirty (30) a period for reply is specified above, the maximum stature to reply within the set or extended period for reply within the set of the	CATION. i 37 CFR 1.136(a). In no evenication. days, a reply within the statuatory period will apply and will lil, by statute, cause the appli	nt, however, may a reply be tim tory minimum of thirty (30) days expire SIX (6) MONTHS from cation to become ABANDONED	ely filed s will be considered timely. the mailing date of this commu O (35 U.S.C. § 133).	unication.
	ORTENED STATUTORY PERIOD FO	R REPLY IS SET TO	DEXPIRE 3 MONTH(S) FROM	
Period fo	The MAILING DATE of this communic or Reply	ation appears on the	cover sheet with the c	orrespondence addres	ss
		Shamim A		1765	
	Office Action Summary	Examiner		Art Unit	
		10/662,93	4	MORLEY ET AL.	
		Application	n No.	Applicant(s)	<i>\bigvert</i>

DETAILED ACTION

Drawings

1. Figure 1 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

Claim Rejections - 35 USC § 112

- The following is a quotation of the second paragraph of 35 U.S.C. 112:
 The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter, which the applicant regards as his invention.
- 3. Claims 20-21 and 23-32 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 4. Claim 20 recites the limitation "the relative etch rate" in line 3 is indefinite because it is unclear whether the etch rate is relative to masked and unmasked areas or relative to the mask and the substrate.
- 5. Claim 23 recites the limitation "the resist mask comprising a plurality of mask openings and mask lands areas **sized and spaced**" in lines 2-3 is indefinite because it is unclear whether both the openings and lands are sized and spaced or only mask lands are sized and spaced.
- 6. Claim 30 recites the limitation "a plurality of mask openings and mask lands areas that are **sized and spaced**" in lines 2- 3 is indefinite because it is unclear whether

both the openings and lands are sized and spaced or only mask lands are sized and spaced.

Claim Rejections - 35 USC § 102

7. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 8. Claims 1-3, 11,13-22 and 30 are rejected under 35 U.S.C. 102(b) as being anticipated by Pasco (5,846,442).

Pasco discloses a single step, partial etching process to provide a contoured feature by applying a patterned photoresist mask with a plurality of openings and mask land features to a substrate, wherein the widths and spacing of the mask land features are selected in such that the etch depth in the transition area such as corner, fillet radius, slope or rounded edge is less than the etch depth to an adjacent or partially etched area of the substrate (see abstract, col.3, lines 63-col.4, lines 67).

As to claim 19, Pasco also teaches that the widths and spacing of the plurality of mask openings and masked land areas are selected in such that the etched features having transition areas with reduced corner rounding (see figure 1D).

As to claim 21, Pasco discloses that the partial etching process can be used to fabricate head suspension assembly (col.5, lines 11-23).

So, Pasco inherently teaches the substrate comprises steel.

As to claim 22, Pasco's plurality of mask openings and mask lands includes the

claimed at least first, second and third mask area.

As to claim 30, Pasco's teaching of the contoured features formed in the

substrate resembles with the claimed texturing the substrate surface.

9. Claims 23-29 are rejected under 35 U.S.C. 102(b) as being anticipated by

Misaka et al (5,421,934).

Miska et al teach a process of etching a substrate, wherein applying a patterned

resist mask to a substrate and the resist mask comprising a plurality of mask openings

and lands areas are sized and spaced in such that etching is advanced in the direction

of depth as compared with in a lateral direction and etching rate in the direction of depth

increases with the incremental increase of the width of the hole or opening (col.12, lines

7-12 and figure 9a).

Claim Rejections - 35 USC § 103

10. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all

obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior at are such that the subject matter as a whole would have been obvious at the time the

the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains.

Patentability shall not be negatived by the manner in which the invention was made.

11. Claims 4-10, 12 and 31-32 are rejected under 35 U.S.C. 103(a) as being

unpatentable over Pasco (5,846,442) as applied to claims 1-3,11,13-22 and 30 above.

and further in view of Dautartas et al (5,935,451).

Pasco discussed above in the paragraph 6 but remain silent about the diameter of the mask land areas in the range of about 10-100 microns.

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However, in a method of etching a substrate, Dautartas et al teach that the distance between etched portions or the average distance between the mask land areas is 10 micrometer (microns), but would vary depending upon the etchant (col.2, lines 46-63).

Therefore, it would have been obvious to one skilled in the art at the time of claimed invention to combine Dautartas et al's teaching into Pasco's process for quickly and economically form etched features with predetermined distance there between by controlling the spacing between the mask as taught by Dautartas et al.

As to claims 7-10, it would have been obvious to one skilled in the art at the time of claimed invention to optimize the same, since it has been held that discovering the optimum value of a result effective variable involves only routine skill in the art. *In re Boesch*, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

As to claim 12, prior to the application of the masking layer, it would have been obvious to one of ordinary skilled in the art at the time of claimed invention to perform an etching the base substrate for achieving the desired substrate thickness and /or having a contamination free surface.

As to claims 31-32, it would have been obvious to have a smooth or rough surface after etching/texturing the substrate.

Art Unit: 1765

Conclusion

- 12. The prior art made of record listed in PTO-892 and considered pertinent to applicant's disclosure.
- 13. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA April 14, 2005